MAY 0 8 2006

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SCULLY, SCOTT, MURPHY & PRESSER



To:	Examiner Chuong A. Luu	From:	Steven Fischman				
Fax:	(571) 273-8300	15 pages including cover sheet					
Phone:		Date:	5/8/2006				
Re:	U.S. Serial No: 10/709,239 Group Art Unit: 2818 Confirmation No: 3238 Docket No: FIS920030375US1 (1719)	CC:					
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;5167424366 # 2/1

CERTIFICATE OF Applicant(s): Huilong Z	Docket No. FIS920030375US1 (17192)									
Application No. 10/709,239	Filing Date April 23, 2004	Examiner Chuong A. Luu	Group Art Unit 2818							
CHANNELS	Invention: STRUCTURES AND METHODS FOR MANUFACTURING OF DISLOCATION FREE STRESSED CHANNELS IN BULK SILICON AND SOI CMOS DEVICES BY GATE STRESS ENGINEERING WITH SiGe AND/OR Si:C									
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on May 8, 1 (Date)		•								
		Steven Fisc	chman							
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AMEND Applicant(s): Hu	rge En	tity)		Docket No. FIS920030375US1 (17192)				
Application No. 10/709,239	Filing Date April 23, 2004	Examiner Chuong A. Luu		Customer No 23389	3.	Group Art Unit 2818	Confirmation No. 3238	
Invention: STRUCTURES AND METHODS FOR MANUFACTURING OF DISLOCATION FREE STRESSED CHANNELS IN BULK SILICON AND SOI CMOS DEVICES BY GATE STRESS ENGINEERING WITH SIGE AND/OR Si;C								
COMMISSIONER FOR PATENTS:								
		n the above-identified a mitted as shown below.		n.				
		CLAIMS AS AM	ENDED)				
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	İ	PRESENT		RATE	ADDITIONAL FEE	
TOTAL CLAIMS	24	24 =	-			\$50.00	\$0.00	
INDEP. CLAIMS	10 -	10 =		`O :	X	\$200.00	\$0.00	
Multiple Dependent Claims (check if applicable)								
		TOTAL ADDITIONAL F	FEE FO	R THIS AME	ND	MENT	\$0.00	
No additional fee is required for amendment. Please charge Deposit Account No. in the amount of A check in the amount of to cover the filing fee is enclosed. The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 09-0458/IBM Any additional filing fees required under 37 C.F.R. 1.16. Any patent application processing fees under 37 CFR 1.17. Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.								
	Signature		Dated	: May 8, 20	vo			
Steven Fischman Registration No. 34,594 SCULLY, SCOTT, MURPHY & PRESSER 400 Garden City Plaza, Suite 300 Garden City, New York 11530 (516) 742-4343				Narreby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on (Date) Signature of Person Mailing Correspondence				
cc:				Typed or Printed Name of Person Mailing Correspondence				

(g)/							cket No. 375US1 (17192)	
Applicant(s). Italiong Zitt, et al.							373031 (17192)	
Application No.	Filing Date	Examiner		Customer N	ю.] (Group Art Unit	Confirmation No.	
10/709,239	April 23, 2004	Chuong A. Luu		23389		2818	3238	
Invention: STRUCTURES AND METHODS FOR MANUFACTURING OF DISLOCATION FREE STRESSED CHANNELS IN BULK SILICON AND SOI CMOS DEVICES BY GATE STRESS ENGINEERING WITH SiGe AND/OR Si:C								
COMMISSIONER FOR PATENTS:								
Transmitted herew	ith is an amendment in	n the above-identified a	pplicatio	on.				
The fee has been	calculated and is trans	mitted as shown below.						
		CLAIMS AS AM	ENDED	· ·				
	CLAIMS REMAINING	HIGHEST#	NUMBE	ER EXTRA	ŖATE ,		ADDITIONAL	
	AFTER AMENDMENT	PREV. PAID FOR	CLAIMS	PRESENT			FEE	
TOTAL CLAIMS	24 -	24 =		.0	x	\$50.00	\$0.00	
INDEP. CLAIMS	10 -	10 =		0	X	\$200.00	\$0.00	
Multiple Dependent Claims (check if applicable) ☐ \$0.0								
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.00							\$0.00	
No additional fee is required for amendment. Please charge Deposit Account No. in the amount of A check in the amount of to cover the filing fee is enclosed. The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 09-0458/IBM Any additional filing fees required under 37 C.F.R. 1.16. Any patent application processing fees under 37 CFR 1.17. Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card Information and authorization on PTO-2038.								
Steven Fischman	Signature							
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Huilong Zhu, et al. Examiner: Chuong A. Luu

Serial No: 10/709,239 Art Unit: 2818

Filed: April 23, 2004 Docket: FIS920030375US1 (17192)

For: STRUCTURES AND METHODS FOR
MANUFACTURING OF DISLOCATION
FREE STRESSED CHANNELS IN BULK

Dated: May 8, 2006

SILICON AND SOI CMOS DEVICES BY GATE STRESS ENGINEERING WITH

SiGe AND/OR Si:C

Confirmation No: 3238

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

AMENDMENT

Sir:

In connection with filing the above-identified application under 37 C.F.R. §1.53(b), applicants submit the following amendments and remarks for consideration by the Examiner and entry of record in the above-identified patent application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: May 8, 2006

Steven Fischman